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	Application No.	Applicant(s)
Notice of Allowability	10/809,153	KOIKE ET AL.
	Examiner	Art Unit
	Sean P. Shechtman	2125
The MAILING DATE of this communication appear All claims being allowable, PROSECUTION ON THE MERITS IS (herewith (or previously mailed), a Notice of Allowance (PTOL-85) NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RIGOT the Office or upon petition by the applicant. See 37 CFR 1.313	OR REMAINS) CLOSED in this ap or other appropriate communication GHTS. This application is subject to	plication. If not included n will be mailed in due course. THIS
1. This communication is responsive to <u>8/25/05</u> .		
2. ☑ The allowed claim(s) is/are <u>18-46</u> . ✓		
3.	been received. been received in Application No cuments have been received in this of this communication to file a reply ENT of this application. tted. Note the attached EXAMINER is reason(s) why the oath or declara t be submitted. on's Patent Drawing Review (PTO- Amendment / Comment or in the Comment or in the Comment of the drawing he header according to 37 CFR 1.121(national stage application from the complying with the requirements. S AMENDMENT or NOTICE OF ation is deficient. 948) attached Office action of the back) of id).
attached Examiner's comment regarding REQUIREMENT F	FOR THE DEPOSIT OF BIOLOGIC	AL MATERIAL
Attachment(s)		
1. Notice of References Cited (PTO-892)	- -	Patent Application (PTO-152)
2. Notice of Draftperson's Patent Drawing Review (PTO-948)	. 6. ☐ Interview Summary Paper No./Mail Da	
3. Information Disclosure Statements (PTO-1449 or PTO/SB/08 Paper No./Mail Date		ment/Comment
Examiner's Comment Regarding Requirement for Deposit of Biological Material	8. ⊠ Examiner's Statements. □ Other	ent of Reasons for Allowance
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DETAILED ACTION

1. Claims 18-46 are presented for examination. Claims 18-46 have been amended.

Claim Objections

2. Objection withdrawn in light of the amendment.

Claim Rejections - 35 USC § 112

3. Rejections withdrawn in light of the amendment.

Claim Rejections - 35 USC § 102

4. Rejections withdrawn in light of the amendment.

Claim Rejections - 35 USC § 103

5. Rejections withdrawn in light of the amendment.

Allowable Subject Matter

6. Claims 18-46 are allowed.

The following is an examiner's statement of reasons for allowance:

While AAPA teaches designating each manufacturing lot of a plurality of manufacturing lots containing a workpiece as a main objective to be managed and loading an specified number of manufacturing lot on a carrier so as to cause said workpieces contained in respective manufacturing lots to pass along a plurality of manufacturing process flows.

And, Akimoto teaches cassettes containing wafers to be processed under different conditions.

And, Conboy teaches management of automated material handling systems, wherein during processing the wafers are divided into lots or groupings of one or more wafers and a cassette is used to store one or more lots.

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Referring to claim 18, neither AAPA, Akimoto or Conboy, taken either alone or in obvious combination disclose a manufacturing managing method having all the claimed features of applicant's instant invention, specifically including: wafers of specific manufacturing lots already loaded on corresponding carriers are unloaded from the carriers and are mixed-loaded on a specific carrier to process wafers of the specific manufacturing lots in a specific in-process work step at different work conditions in a processing apparatus.

Referring to claim 30, neither AAPA, Akimoto or Conboy, taken either alone or in obvious combination disclose a manufacturing managing method having all the claimed features of applicant's instant invention, specifically including: a plurality of specific manufacturing lots of wafers requiring a specific in-process work step of each of a plurality of processing apparatuses are selected from manufacturing lots, and the wafers of the specific manufacturing lots already loaded on corresponding carriers are mix-loaded on a specific carrier.

Referring to claim 35, neither AAPA, Akimoto or Conboy, taken either alone or in obvious combination disclose a manufacturing managing method having all the claimed features of applicant's instant invention, specifically including: wafers of similar manufacturing lots already loaded on corresponding carriers are unloaded from the carriers and are mix-loaded on a specific carrier to process the wafers of the similar manufacturing lots in a specific in-process work step at the same work condition in a processing apparatus.

It is for these reasons that applicant's invention defines over the prior art of record. Claims 19-29, 31-34, and 36-46 depend from claims 18, 30, and 35 and are therefore also allowable.

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Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

Conclusion

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Sean P. Shechtman whose telephone number is (571) 272-3754. The examiner can normally be reached on 9:30am-6:00pm, M-F.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Leo P. Picard can be reached on (571) 272-3749. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

L-PP

SPS

Sean P. Shechtman

LEO PICARD
SUPERVISORY PATENT EXAMINER
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September 15, 2005